



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 8, 2026	
IGI Report Number	LG800626350
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.51 - 6.56 X 3.91 MM

GRADING RESULTS

Carat Weight	1.03 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	EXCELLENT

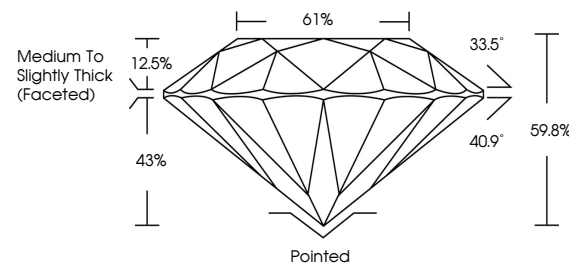
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG800626350

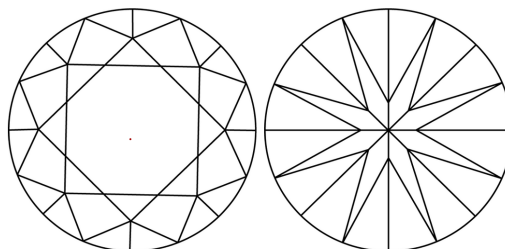
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG800626350
Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

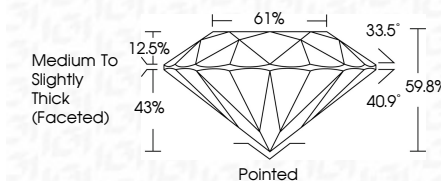
FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



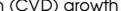
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www.igi.org

May 8, 2005	GL Record No. L2000263550	ROUND BRILLIANT	1.08 CARAT
			D
			VVS 2
			EXCELLENT
			69.6%
			Medium To Slightly Thick (faceted)
			Painted
			EXCELLENT
			EXCELLENT
			NONE
			161 L2000263550

Comments:
 1. Crown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
 2. Type IIG